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PTO/SB/08A (08-00)  
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<b>Substitute for form 1449A/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/783,386
				Filing Date	February 20, 2004
				First Named Inventor	Larry F. Rhodes
				Group Art Unit	1752
				Examiner Name	Not Yet Assigned A. Walker
				Attorney Docket Number	4262-031384
Sheet	1	of	2		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup>			
ACW	AA	6,455,650	B1	Lipian et al.	09-24-2002	
	AB	6,136,499	A	Goodall et al.	10-24-2000	
	AC	6,124,074	A	Varanasi et al.	09-26-2000	
	AD	6,121,340	A	Shick et al.	09-19-2000	
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	AI	4,371,605		Renner	02-01-1983	
ACW	AJ	4,250,053		Smith	02-10-1981	

FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>2</sup>
		Office <sup>3</sup>	Number <sup>4</sup>				

Examiner Signature	Amanda C. Walker	Date Considered	2/13/06
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		Attorney Docket Number	4262-031384

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, cite and/or country where published.	T <sup>2</sup>
<i>AW</i>	AK	JEFFREY et al., "Metal complexes of hemilabile ligands. Reactivity and structure of dichlorobis(o-(diphenylphosphino)anisole)ruthenium(II)," <u>Inorg. Chem.</u> , 1979, pp. 2658-2666, Vol. 18, No. 10.	
	AL	BADER et al., "Coordination chemistry and catalysis with hemilabile oxygen-phosphorus ligands," <u>Coord. Chem. Rev.</u> , 1991, pp. 27-110, Vol. 108.	
	AM	SLONE et al., "The Transition Metal Coordination Chemistry of Hemilabile Ligands," <u>Prog. Inorg. Chem.</u> , 1999, pp. 233-350, Vol. 48.	
	AN	REICHMANIS et al., "Chemical Amplification Mechanisms for Microlithography," <u>Chem. Mater.</u> , 1991, pp. 394-407, Vol. 3.	
	AO	HAMAD et al., "Fluorinated Dissolution Inhibitors for 157 nm Lithography," <u>Advances in Resist Technology and Processing XIX, Proceedings of SPIE</u> , 2002, pp. 477-485, Vol. 4690.	
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	AQ	WILLSON et al., "Fluorinated Polymers and Dissolution Inhibitors for 157nm Microlithography," <u>Polymeric Materials: Science &amp; Engineering</u> , 2002, pp. 396-397, Vol. 87.	
	AR	CONLEY et al., "Dissolution Inhibitors for 157 nm Lithography: A Progress Report," <u>J. Photopolym. Sci. Technol.</u> , 2002, pp. 613-617, Vol. 15, No. 4.	
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<i>AW</i>	AT	TRAN et al., "Metal-Catalyzed Vinyl Addition Polymers for 157 nm Resist Applications. 2. Fluorinated Norbornenes: Synthesis, Polymerization, and Initial Imaging Results," <u>Macromolecules</u> , 2002, pp. 6539-6549, Vol. 35.	

Examiner Signature	<i>Aminda C Walker</i>	Date Considered	2/13/06
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